



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 17, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG668407376

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT

7.45 X 4.98 X 3.40 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.07 CARAT

J

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

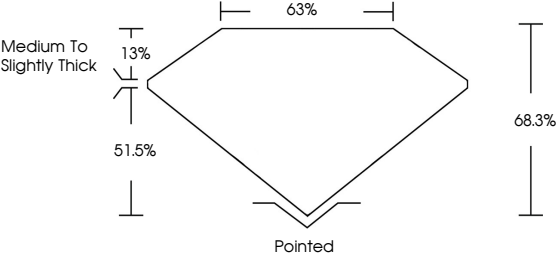
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



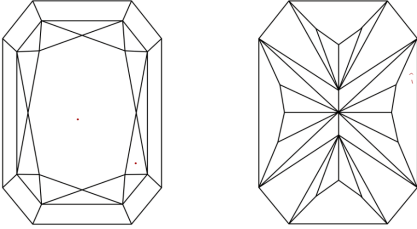
LG668407376

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J

Faint Very Light Light

CLARITY

IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



December 17, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG668407376

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

7.45 X 4.98 X 3.40 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.07 CARAT

J

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG668407376



IGI

December 17, 2024

IGI Report No LG668407376

CUT CORNERED RECT. MODIFIED BRILLIANT

7.45 X 4.98 X 3.40 MM

Carat Weight

Color Grade

Clarity Grade

Table

Depth

Graile

Medium to Slightly Thick

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.07 CARAT

J

VVS 2

68.3%

63%

Medium to Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE



Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa